

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)

0EKM-104599

Application Number

10/634,023

Applicant(s)

Drew T. De Shiell, et al.

Filing Date

August 4, 2003

Group Art Unit

3711

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
SP	5,328,176	07/12/1994	Lo	273	167	06/10/1993
SP	5,410,798	05/02/1995	Lo	29	527	01/06/1994
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REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
SP	2002-165902	11/06/2002	Japan			✓	
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER

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DATE CONSIDERED

12-23-04

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INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Document Number (Optional) 0EKM-104599		Application Number 10/634,023	
				Applicant(s) Drew T. DeShiel et al.			
				Filing Date 08/04/2003		Group Art Unit 3711	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	REV	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
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EXAMINER INITIAL	REV	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
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FOREIGN PATENT DOCUMENTS							
REV	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
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